

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 10, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG755518967

LABORATORY GROWN DIAMOND

EMERALD CUT

9.53 X 6.95 X 4.80 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.10 CARATS

E

VS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG755518967

PROPORTIONS

Medium

64%

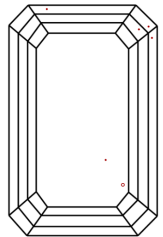
14.5%

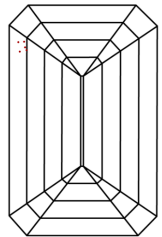
51%

69.1%

Long

CLARITY CHARACTERISTICS






KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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
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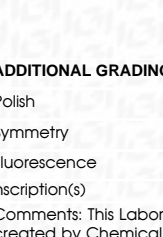
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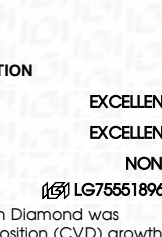
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IGI





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EMERALD CUT

3.10 CARATS

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Clarity Grade

Depth

Graile

E

VS 2

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Medium

Long

EXCELLENT

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NONE

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Culet

Polish

Symmetry

Fluorescence

Inscription(s)

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Excellent

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